

Homogeneous Codes for Energy-Efficient Illumination and Imaging

ACM SIGGRAPH 2015

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Motivation

Goal

- How can we use energy most effectively in structured light applications?

Applications

- Distinguish between translucency and inter-reflections
- Remove artifacts caused by structured light
- Reconstruct 3D objects in challenging conditions (smoke, strong lights)
- Record live video from the projector's point of view
- Capture structured light video of very bright scenes
 - Outdoor gesture recognition

Challenges

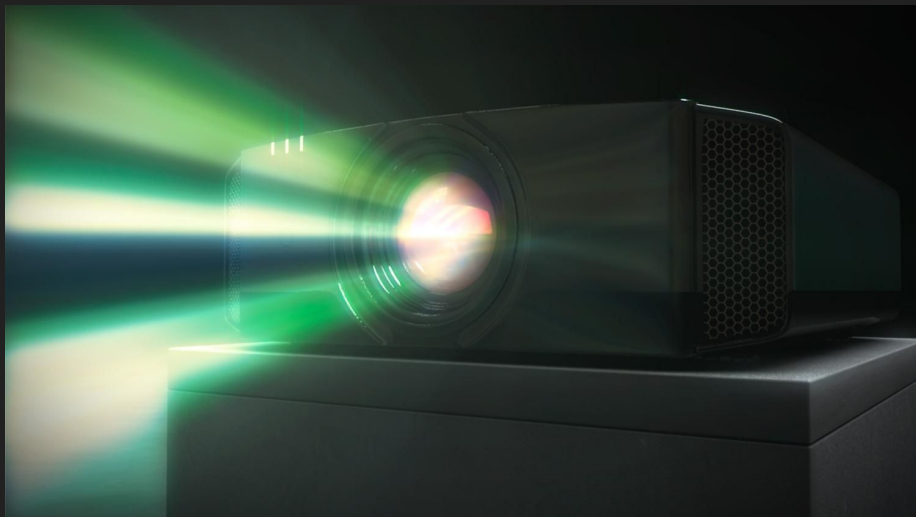
- Masks are inefficient (blocked photons are wasted)
 - Required for light-field displays and indirect-only photography
- Live imaging requires short exposures
- Devices used are low-powered
- Photons emitted can cause unwanted artifacts in the image

Setup



VSYNC chip

- Rolling Shutter Camera
- Digital Micromirror Device (DMD) Projector
- A Laser Impulse Projector



Imaging with Rolling Shutter Cameras

- A single exposure is taken over hundreds of microseconds
- Each row at a slightly different time
- Rolling shutter



Illumination patterns and masks

- Projector sends out an illumination pattern
- Camera sensor records single rows (masked)

- Exploit these two phenomena to efficiently capture photons

Spectrum of projectors



Energy Efficiency

Total Energy generated by Projector

$$0 \leq \mathbf{1}, \quad \|\mathbf{1}\|_1 \leq \Phi T,$$

T is the total time

ϕ is the constant wattage of the light source

I is the illumination pattern (energy emitted by each projector pixel)

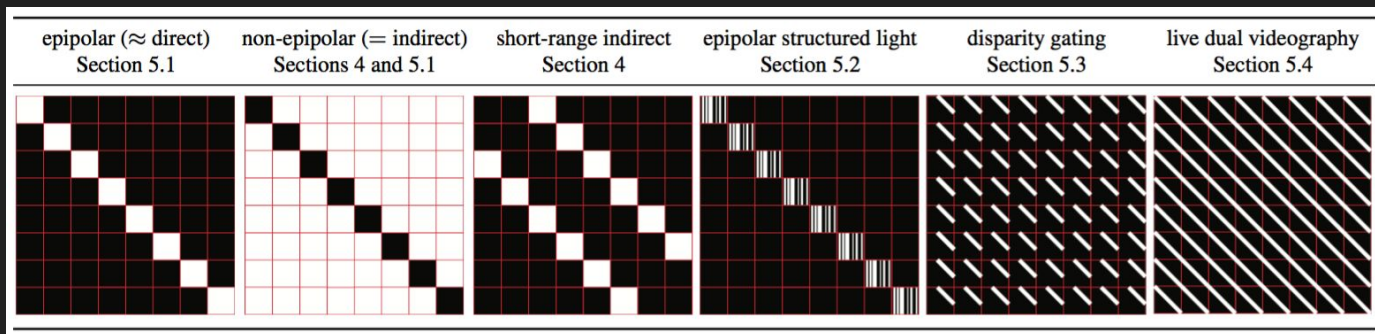
Redistribution Factor

$$\|\mathbf{1}\|_\infty \leq \Phi T / \sigma,$$

σ is the redistribution factor. This can range from 1 to N , where 1 means the projector is able to redirect all power from turned off pixels to one that are on.

$$0 \leq \mathbf{1}, \quad \|\mathbf{1}\|_{\dagger\sigma} = \max\left(\frac{\sigma\|\mathbf{1}\|_\infty}{\Phi}, \frac{\|\mathbf{1}\|_1}{\Phi}\right) \leq T,$$

Masks



$$0 \leq \mathbf{m}, \quad \|\mathbf{m}\|_{\infty} \leq 1.$$

Masks attenuation

$$\gamma \mathbf{\Pi} = \mathbf{m} \mathbf{l}^T,$$

Probing matrix & energy efficiency

\mathbf{m} is a vector with each element is 0 to 1 that describes the mask attenuation on the sensor

γ : the scalar energy efficiency in Joules

$\mathbf{\Pi}$: unit-less probing matrix (examples below)

High-Rank Probing Matrices

- High-rank probing matrices require changing the illumination $K > 1$ over the exposure time

$$\gamma \mathbf{\Pi} = \sum_{k=1}^K \mathbf{m}_k (\mathbf{l}_k)^T,$$

$$0 \leq t_k, \quad \sum_{k=1}^K t_k \leq T,$$

$$0 \leq \mathbf{m}_k, \quad \|\mathbf{m}_k\|_{\infty} \leq 1, \quad 0 \leq \mathbf{l}_k, \quad \|\mathbf{l}_k\|_{\dagger\sigma} \leq t_k,$$

Homogeneous Factorization

We want to maximize the energy efficiency

$$\gamma \mathbf{\Pi} = \underbrace{[\mathbf{m}_1 \ \mathbf{m}_2 \ \cdots \ \mathbf{m}_K]}_{\text{masks } \mathbf{M}} \underbrace{[\mathbf{l}_1 \ \mathbf{l}_2 \ \cdots \ \mathbf{l}_K]}_{\text{illuminations } \mathbf{L}}^T$$

$$\max_{\gamma, \mathbf{M}, \mathbf{L}, t_1, \dots, t_K}$$

$$\gamma$$

subject to

$$\gamma \mathbf{\Pi} = \mathbf{ML}^T$$

$$0 \leq \mathbf{m}_k, \quad \|\mathbf{m}_k\|_\infty \leq 1$$

$$0 \leq \mathbf{l}_k, \quad \|\mathbf{l}_k\|_{\dagger\sigma} \leq t_k$$

$$0 \leq t_k, \quad \sum_{k=1}^K t_k \leq T.$$

Homogeneous Factorization Part 2

We relax the previous equation to solve more easily.

$$\begin{aligned} \min_{\mathbf{M}, \mathbf{L}} \quad & \|\mathbf{\Pi} - \mathbf{M}\mathbf{L}^T\|_F^2 + \lambda \sum_{k=1}^K \|\mathbf{m}_k\|_\infty \|\mathbf{l}_k\|_{\dagger\sigma} \\ \text{subject to} \quad & 0 \leq \mathbf{m}_k, 0 \leq \mathbf{l}_k \end{aligned}$$

λ is the regularization parameter which balances energy efficiency and the reproduction of the probing matrix

Details of how this equation is derived can be found in the appendix

Homogeneous Factorization Part 3

By dropping the non-negativity constraints and leaving the sequence \mathbf{K} unconstrained, we get:

$$\min_{\mathbf{X}} \quad \|\mathbf{\Pi} - \mathbf{X}\|_F^2 + \lambda h(\mathbf{X}) \quad (13)$$

where function $h(\mathbf{X})$ is the *projective tensor norm*, defined as

$$h(\mathbf{X}) = \min_{\mathbf{X}=\mathbf{ML}^T} \left\{ \sum_{k=1}^K \|\mathbf{m}_k\|_p \|\mathbf{l}_k\|_q \right\} \quad (14)$$

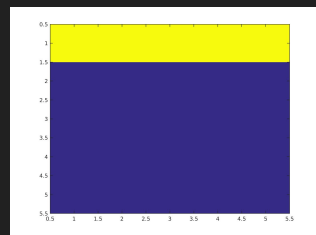
$$= \min_{\mathbf{X}=\mathbf{ML}^T} \left\{ \frac{1}{2} \sum_{k=1}^K \|\mathbf{m}_k\|_p^2 + \|\mathbf{l}_k\|_q^2 \right\} \quad (15)$$

with $p = \infty$ and $q = \dagger\sigma$ according to Eq. (12).

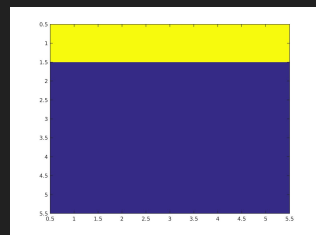
What does this homogeneous factorization mean?

- Impulse illumination is globally optimal
- For DMDs we need to create a code which will be energy efficient
- Epipolar illumination is globally optimal for epipolar and non-epipolar imaging
- Epipolar illumination and epipolar masking confer robustness to ambient light

Producing probing matrices



Illumination
(5x5)



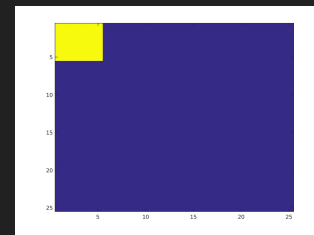
Camera Mask
(5x5)



Illumination
(25x1)



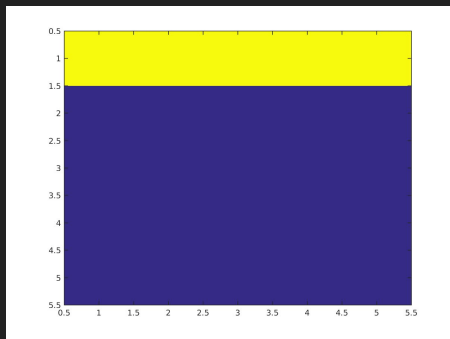
Camera Mask
(1x25)



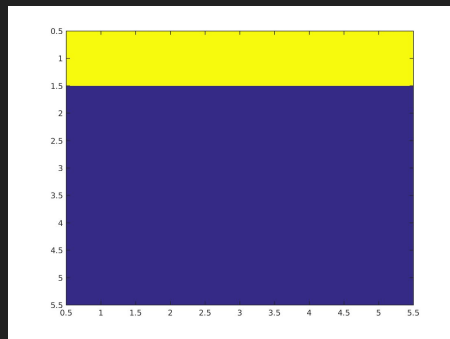
Probing Matrix
(25x25)

Producing probing matrices

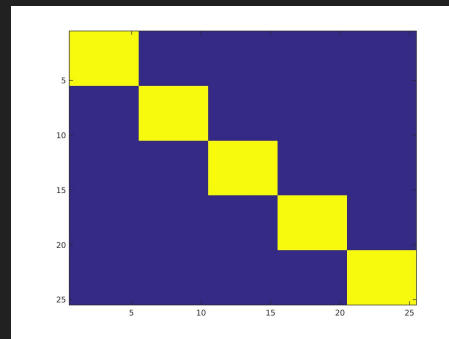
- Epipolar probing



Illumination
(5x5)



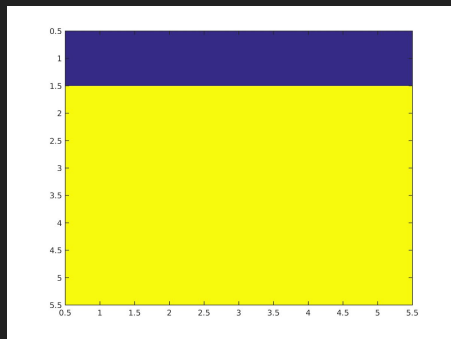
Camera mask
(5x5)



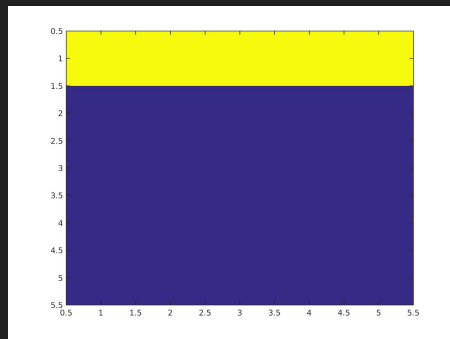
Probing Matrix
(25x25)

Producing probing matrices

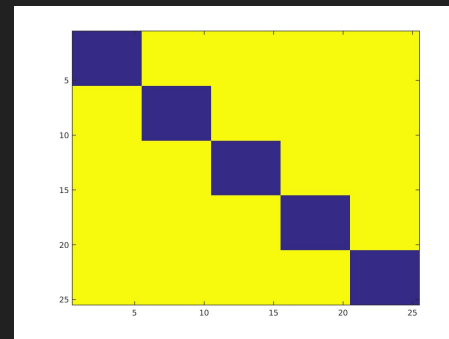
- Non-epipolar probing



Illumination
(5x5)



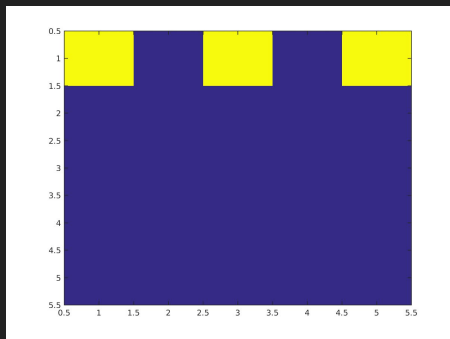
Camera mask
(5x5)



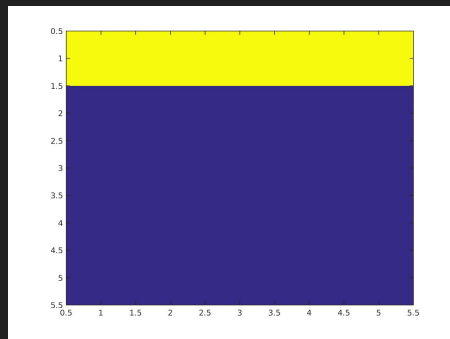
Probing Matrix
(25x25)

Producing probing matrices

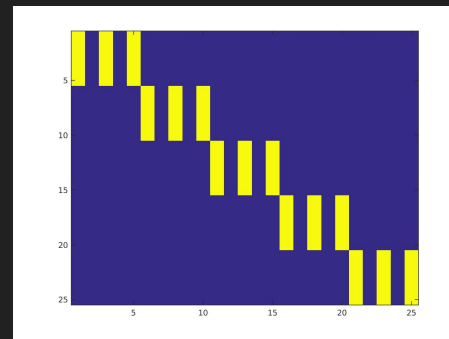
- Structured light



Illumination
(5x5)



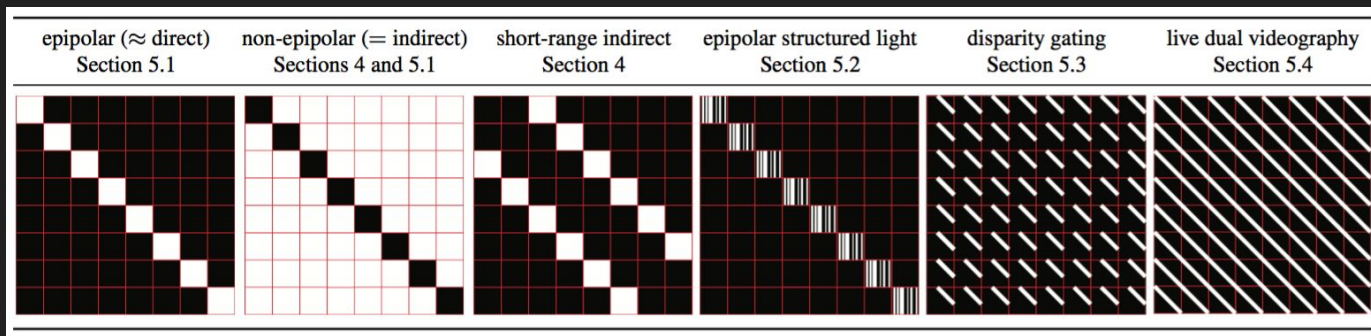
Camera mask
(5x5)



Probing Matrix
(25x25)

Producing probing matrices

- Different probing matrices capture different characteristics of the scene



Producing probing matrices

- Can we go in the other direction?
 - Factorization
 - Maximize efficiency while doing this



Imaging with DMDs

- Distributes power over the entire screen ($\sigma=N$)
- Requires solving the factorization to produce the illumination pattern and mask

Imaging with DMDs

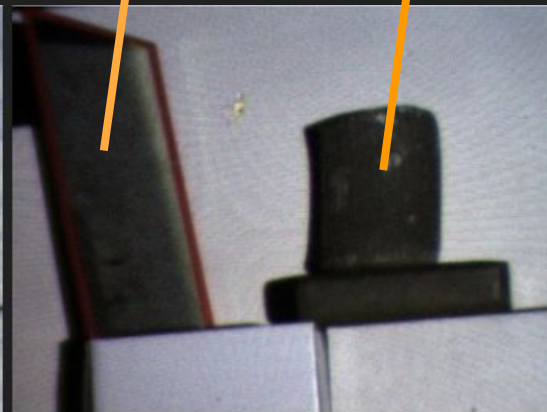
- Epipolar imaging



Original scene



Results from 2014



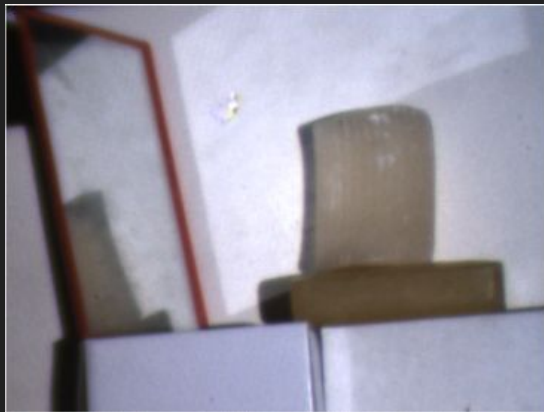
Mirror

Candle

This paper

Imaging with DMDs

- Non-epipolar imaging



Original scene



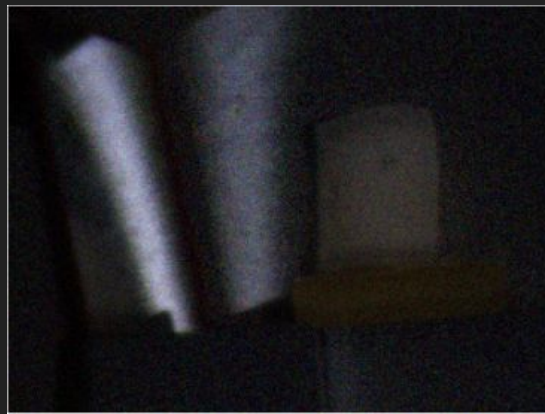
Results

Imaging with DMDs

- Allows probing matrices with high ranks too!



Non-epipolar / Indirect lighting

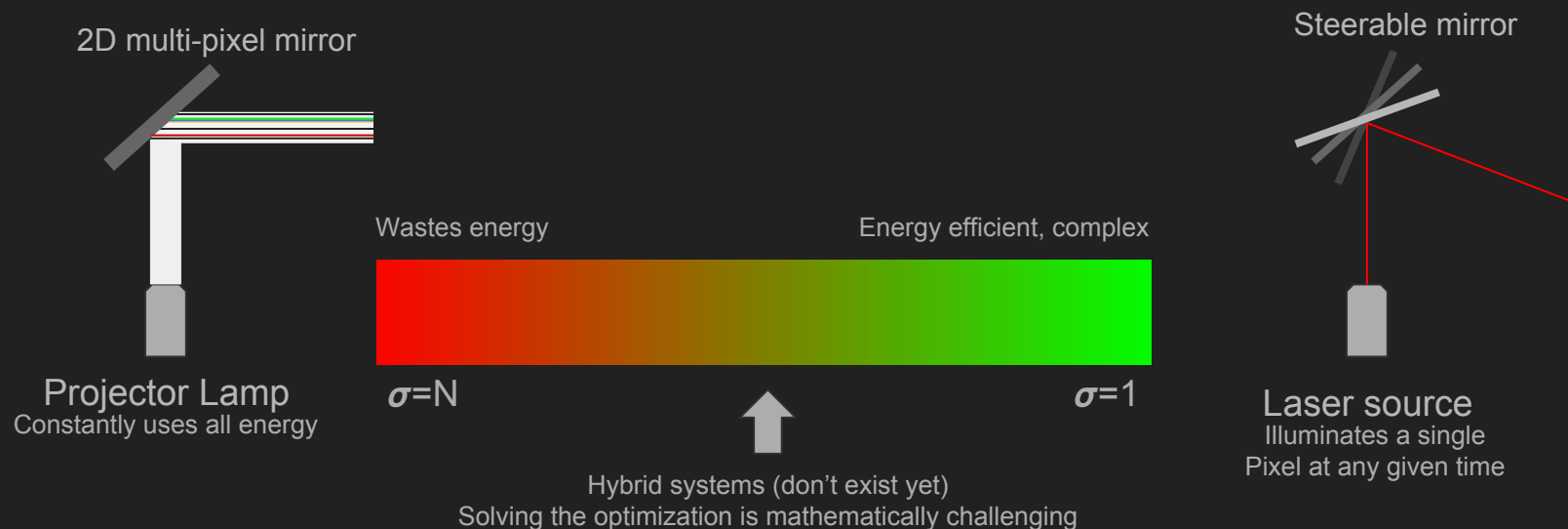


Short-range indirect



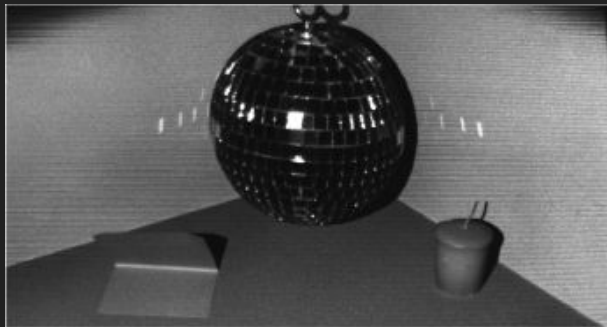
Long-range indirect

Spectrum of projectors

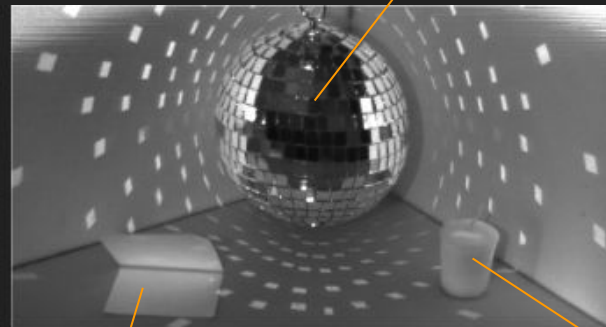


Imaging with Laser Projectors

- Epipolar and Non-epipolar imaging
 - Can be achieved in real-time



Epipolar imaging



Non-epipolar imaging

Inter-reflections

High specularity

Translucency

Imaging with Laser Projectors

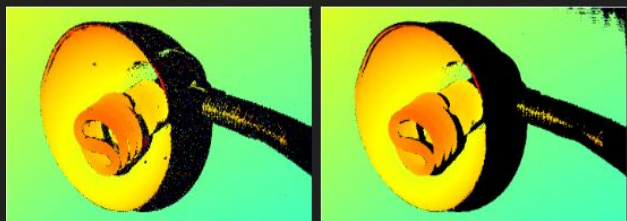
- Problems
 - The projector's scanlines aren't perfect
 - Thicken the region to accommodate errors



Imaging with Laser Projectors

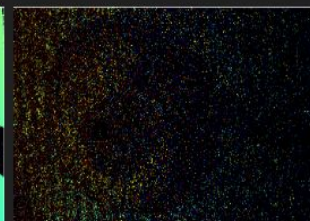
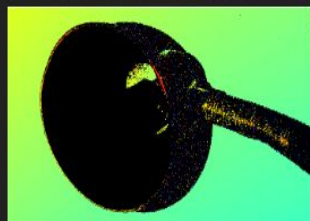
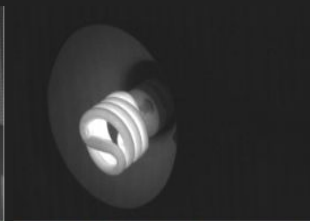
- Epipolar structured light

Reducing the iris size

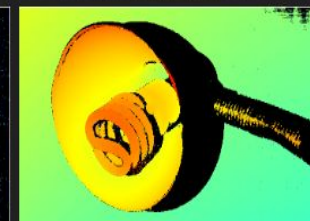
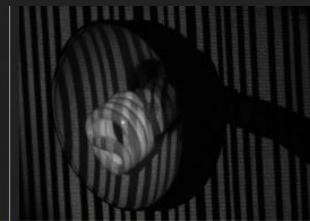


Lamp off

Reducing the iris size



Lamp on



Imaging with Laser Projectors

- Epipolar structured light

Structured Light Outdoors

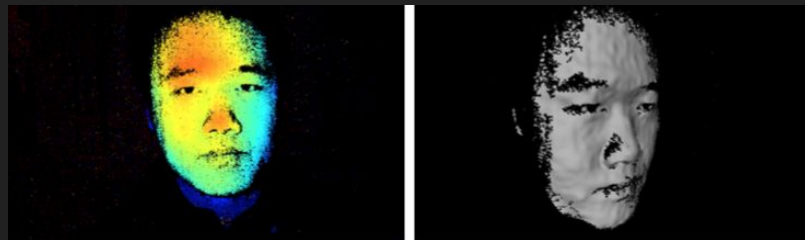
Regular Imaging



Epipolar-Only Imaging

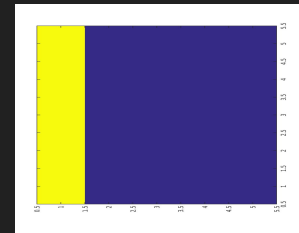
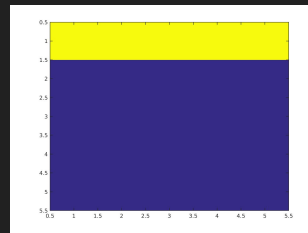


Ambient Light Level = 80,000 lux



Imaging with Laser Projectors

- Disparity Gating
 - Allows triangulating a point
 - The illumination pattern and camera mask allow us to locate the position of a pixel



- Rotate the camera 90 degrees
- Set a depth plane
- Capture images

Projector

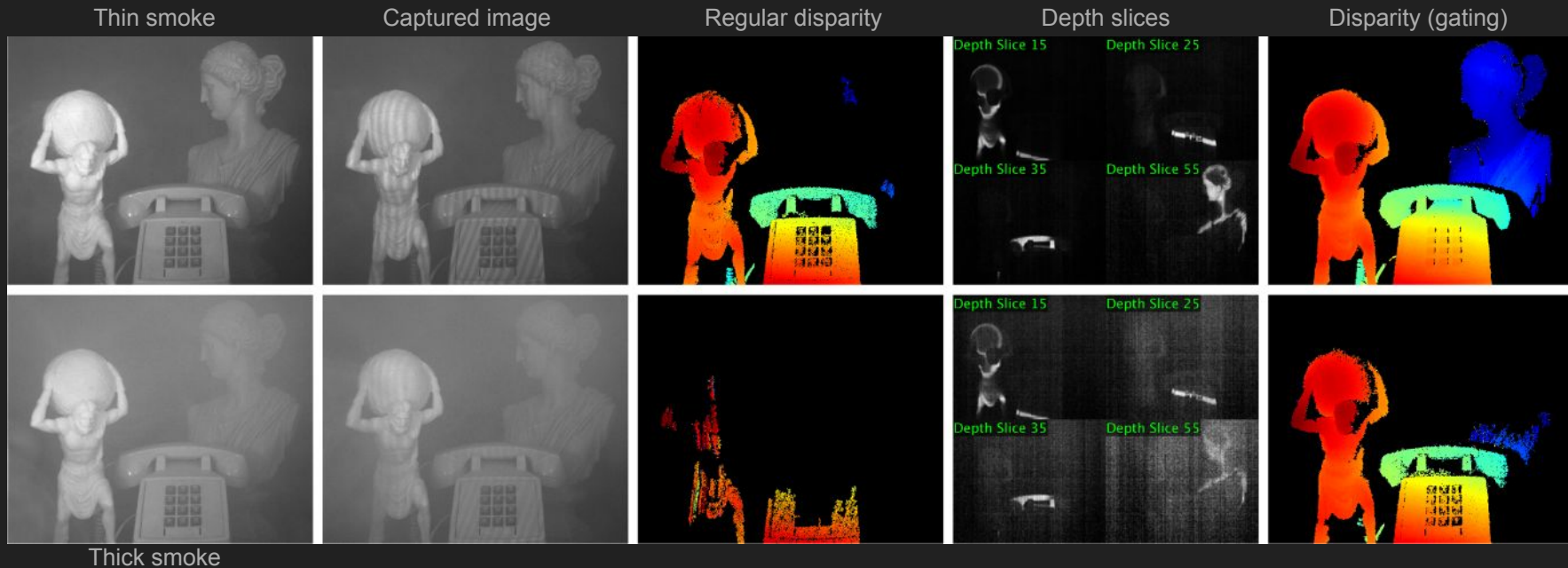
Camera

Projector

Camera



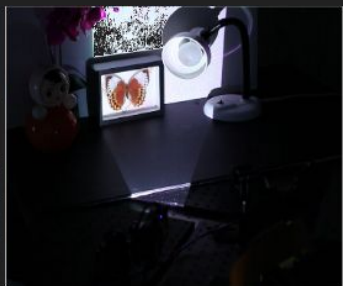
Imaging with Laser Projectors



Imaging with Laser Projectors



- Dual Videography
 - Similar to Disparity Gating but with the plane at infinity
 - Capturing the physical transport matrix is still challenging
 - This method captures an approximate epipolar image from the projector's view



Conclusion

- Energy efficient codes produce sharp, artifact-free images
- **Rating: 1.0**



- **Pros**
 - Uses physical limitations of the sensor
 - Produces sharp images
 - Uses off-the-shelf components
 - Several applications
 - Poses problem statement for potential future projectors

- **Cons**
 - The math can be hard to understand

Questions?